	Application No.	Applicant(s)	
Notice of Allowability	10/628,260	HIRAKATA ET AL.	
	Examiner	Art Unit	
	Thinh T Nguyen	2818	
The MAILING DATE of this communication appearance All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIPORT of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in or other appropriate communication is sufficiently.	this application. If not included nication will be mailed in due cou	rse. <b>THIS</b>
1. $\boxtimes$ This communication is responsive to <u>6/21/2004</u> .			
2. ⊠ The allowed claim(s) is/are <u>1-24</u> .			
3. $igotimes$ The drawings filed on <u>29 July 2003</u> are accepted by the Ex	aminer.	,	
<ul> <li>4.  Acknowledgment is made of a claim for foreign priority ur</li> <li>a)  All b)  Some* c)  None of the:</li> <li>1.  Certified copies of the priority documents have</li> <li>2.  Certified copies of the priority documents have</li> <li>3.  Copies of the certified copies of the priority do</li> <li>International Bureau (PCT Rule 17.2(a)).</li> </ul>	been received. been received in Application	No	from the
* Certified copies not received:			
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		a reply complying with the require	ements
5. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give			CE OF
6. CORRECTED DRAWINGS ( as "replacement sheets") mus	at be submitted.		
(a) including changes required by the Notice of Draftspers	on's Patent Drawing Review	( PTO-948) attached	
1)  hereto or 2)  to Paper No./Mail Date			
(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date	s Amendment / Comment or i	n the Office action of	
Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in t			ck) of
<ol> <li>DEPOSIT OF and/or INFORMATION about the depo- attached Examiner's comment regarding REQUIREMENT</li> </ol>			the
Attachment(s) 1. ⊠ Notice of References Cited (PTO-892)	5. □ Notice of Info	rmal Patent Application (PTO-15	52)
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. ☐ Interview Sur	* *	<i></i> ,
3. ⊠ Information Disclosure Statements (PTO-1449 or PTO/SB/0	Paper No./M	lail Date mendment/Comment	
Paper No./Mail Date4. ☐ Examiner's Comment Regarding Requirement for Deposit		tatement of Reasons for Allowar	nce
of Biological Material	9. Other	The state of the s	. <u>-</u>
	Dávið Nelms Supervisory Patent Examiner Technology Center 2800		

## **DETAILED ACTION**

## Examiner's Amendment.

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Since the Applicant elects claims 1-24 for prosecution without traverse in the communication with the Office on 6/21/2004. Non-elected claims 25-44 are cancelled.

## **Specification**

2. The specification has been checked to the extent necessary to determine the presence of all possible minor errors. However, the applicant cooperation is requested in correcting any errors of which the applicant may become aware in the specification.

## Reason for allowance

3. The following is an examiner's statement of reason for allowance: None of the references of record teaches or suggests the claimed **ORGANIC THIN FILM TRANSISTOR AND** 

Application/Control Number: 10/628,260 Page 3

Art Unit: 2818

METHOD OF MANUFACTURING THE SAME, AND SEMICONDUCTOR DEVICE

HAVING THE ORGANIC THIN FILM TRANSISTOR having the limitations:

-- " forming an opening portion in the second insulating film over the first

conductive film; "--

--" superimposing a second substrate over the first substrate; and injecting a solution

containing an organic material and a solvent into the opening portion. "--

and all other limitations as recited in claim 1 and 2.

Any comments considered necessary by applicant must be submitted no later than the

payment of the issue fee and, to avoid processing delays, should preferably accompany the issue

fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for

Allowance".

3. When responding to the office action, Applicants are advised to provide the examiner

with the line numbers and the page numbers in the application and/or references cited to assist

the examiner to locate the appropriate paragraphs.

4. Receipt is acknowledged of papers submitted under 35 U.S.C. 119(a)-(d) which papers

have been placed of record in the file.

Conclusion

Application/Control Number: 10/628,260

Art Unit: 2818

5. The prior art made of record and not relied upon is considered pertinent to applicant's

disclosure: Morozuni (US patent 6,432,845) disclose a semiconductor device and method for

making the same.

6. Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Thinh T Nguyen whose telephone number is 571-272-1790.

The examiner can normally be reached on Monday-Friday 9:00am-6:00pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, David Nelms can be reached at 571-272-1787. The fax phone numbers for the

organization where this application or proceeding is assigned are (703) 872-9306 for regular

communications and (703) 872-9319 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding

should be directed to the receptionist whose telephone number is (703) 308-0956.

Thinh T Nguyen TW

Art unit 2818

Bavid Nelms
Supervisory Patent Examiner

Page 4

Technology Center 2800